



**ELECTRONIC COPY**

LG795607007  
Report verification at igi.org



April 30, 2026  
IGI Report Number **LG795607007**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUSHION MODIFIED BRILLIANT**  
Measurements **10.79 X 8.29 X 5.72 MM**  
**GRADING RESULTS**  
Carat Weight **4.02 CARATS**  
Color Grade **F**  
Clarity Grade **VS 2**

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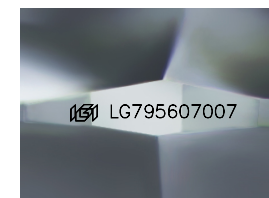
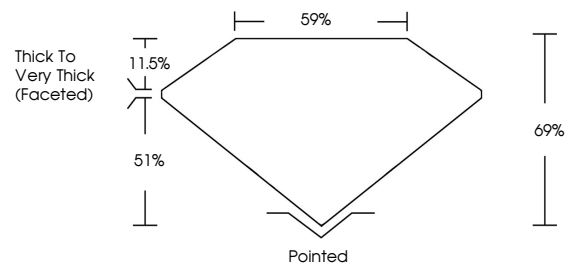
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Color Grade **F**  
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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG795607007**

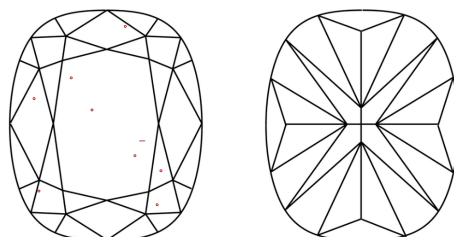
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

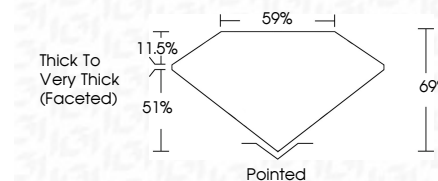
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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IGI Report No **LG795607007**  
**CUSHION MODIFIED BRILLIANT**  
**10.79 X 8.29 X 5.72 MM**  
**4.02 CARATS**  
**F**  
**VS 2**  
**69%**  
**51%**  
**Thick to Very Thick (Faceted)**  
**Pointed**  
**EXCELLENT**  
**EXCELLENT**  
**NONE**  
**IGI LG795607007**  
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Type IIa